



**SUPPLEMENTAL INFORMATION
DISCLOSURE STATEMENT BY
APPLICANT PTO-1449**

Docket No. 52433/860	Application No. 10/591,919	
Applicant(s) TANIGUCHI et al.	Examiner Michael E. Lavilla	
Filing Date September 6, 2006	Confirmation No. 5382	Art Unit 1794

U. S. PATENT DOCUMENTS

EXAMINER INITIAL	PATENT/PUBLICATION NUMBER	PATENT/PUBLICATION DATE mm/dd/yyyy	NAME	CLASS	SUBCLASS	FILING DATE

FOREIGN PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE mm/dd/yyyy	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						Yes	No
	EP 1 512 760 A2	March 9, 2005	EP				
	EP 1 707 645 A1	October 4, 2006	EP				
	JP 2000-345288 A	December 12, 2000	JP			Abstract	
	JP 2003-239040 A	August 27, 2003	JP			Abstract	
	JP 2001-207235 A	July 31, 2007	JP			Abstract	

EXAMINER /Rebecca Lee/	DATE CONSIDERED 12/22/2009
EXAMINER: Initial if citation considered, whether or not citation is in conformance with M.P.E.P. 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	